

## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasufumi NISHII et al.

Group Art Unit: 2851

Application No.: 10/582,268

Examiner: M. LIU

Filed: June 9, 2006 Docket No.: 128375

For: STAGE APPARATUS, EXPOSURE APPARATUS, AND EXPOSURE METHOD

## **AMENDMENT FILED WITH RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the July 29, 2008 Office Action, and after entry of the attached Request for Continued Examination (RCE), please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.